

APPENDIX

The following information may be used where applicable:

Elementary charge	q	$= 1.602 \times 10^{-19} \text{ C}$
Permittivity of free space	ϵ_0	$= 8.854 \times 10^{-14} \text{ F cm}^{-1}$
Room temperature		$= 300 \text{ K}$
Thermal voltage at 300 K	V_T	$= kT/q = 0.025 \text{ V} = 25 \text{ mV}$
Intrinsic carrier concentration of silicon at 300 K	n_i	$= 1.5 \times 10^{10} \text{ cm}^{-3}$
Relative permittivity of silicon	$\epsilon_r (\text{Si})$	$= 11.7$
Relative permittivity of silicon dioxide	$\epsilon_r (\text{SiO}_2)$	$= 3.9$

Summary of Equations

I. Semiconductor Physics

<u>Quantity</u>	<u>Equation</u>	<u>Remarks</u>
Law of mass action	$p_0 n_0 = n_i^2$	$n_i = 1.5 \times 10^{10} \text{ cm}^{-3}$ for Si at $T = 300 \text{ K}$
Charge neutrality	$p + N_D = n + N_A$	
Carrier concentrations in p -type semiconductor at thermal equilibrium (cm^{-3})	$p_{p0} = N_A$ $n_{p0} = \frac{n_i^2}{N_A}$	$T = 300 \text{ K}$ N_A = net p -type doping concentration
Carrier concentrations in n -type semiconductor at thermal equilibrium (cm^{-3})	$n_{n0} = N_D$ $p_{n0} = \frac{n_i^2}{N_D}$	$T = 300 \text{ K}$ N_D = net n -type doping concentration
Drift current density (A cm^{-2})	$J_{\text{drift}} = J_{p,\text{drift}} + J_{n,\text{drift}}$ $J_{p,\text{drift}} = qp\mu_p E$ $J_{n,\text{drift}} = qn\mu_n E$ $J_{\text{drift}} = q(p\mu_p + n\mu_n) E = \sigma E$	σ is conductivity, E is electric field
Conductivity ($\Omega \text{ cm}$) ⁻¹	$\sigma = q(p\mu_p + n\mu_n) = \frac{1}{\rho}$	ρ is resistivity
Diffusion current density (A cm^{-2})	$J_{\text{diff}} = J_{p,\text{diff}} + J_{n,\text{diff}}$ $J_{p,\text{diff}} = -qD_p \frac{dp}{dx}$ $J_{n,\text{diff}} = qD_n \frac{dn}{dx}$ $J_{\text{diff}} = -qD_p \frac{dp}{dx} + qD_n \frac{dn}{dx}$	
Einstein Relation	$\frac{D_p}{\mu_p} = \frac{D_n}{\mu_n} = \frac{kT}{q} = V_T$	$k = 1.381 \times 10^{-23} \text{ J/K}$ $= 8.62 \times 10^{-5} \text{ eV/K}$ $q = 1.602 \times 10^{-19} \text{ C}$ $V_T \approx 0.025 \text{ V}$ at $T = 300 \text{ K}$.

II. pn Junction

Quantity	Equation	Remarks
Junction built-in (or barrier) voltage (V)	$V_0 = V_T \ln \left(\frac{N_A N_D}{n_i^2} \right)$	$V_0 \cong 0.6 - 0.8$ V for Si at $T = 300$ K. N_D is the doping concentration of the n -region. N_A is the doping concentration of the p -region.
Width of depletion region (cm or μm)	$W_{dep} = x_p + x_n$ $= \sqrt{\frac{2\epsilon_s}{q} \left[\frac{1}{N_A} + \frac{1}{N_D} \right] (V_0 - V)}$ $x_p = \frac{N_D}{N_D + N_A} W_{dep}, \quad x_n = \frac{N_A}{N_D + N_A} W_{dep}$	V is positive for forward bias and negative for reverse bias $\epsilon_s = 11.7 \times \epsilon_0$ for Si $\epsilon_0 = 8.854 \times 10^{-14}$ F cm^{-1} . x_p is the depletion width in the p -region. x_n is the depletion width in the n -region.
Minority carrier concentration at the edge of depletion region (cm^{-3})	$p\text{-side: } n_p(-x_p) = n_{p0} e^{V/V_T}$ $n\text{-side: } p_n(x_n) = p_{n0} e^{V/V_T}$	= thermal equilibrium minority carrier concentration $\times e^{V/V_T}$
Minority carrier concentration distributions in the neutral n - and p -regions (cm^{-3})	$n\text{-side:}$ $p_n(x) = p_{n0} + [p_n(x_n) - p_{n0}] e^{-(x-x_n)/L_p}$ $p\text{-side:}$ $n_p(x) = n_{p0} + [n_p(-x_p) - n_{p0}] e^{(x+x_p)/L_n}$	L_p, L_n are the diffusion lengths of the minority carriers in the n -side and p -side respectively. In the equations, $x > x_n$ on the n -side, and $x < -x_p$ on the p -side.
Current (A)	$I = I_p + I_n = I_s (e^{V/nV_T} - 1)$ $I_p = A q n_i^2 \frac{D_p}{L_p N_D} (e^{V/nV_T} - 1)$ $I_n = A q n_i^2 \frac{D_n}{L_n N_A} (e^{V/nV_T} - 1)$	n is a value between 1 and 2. I_p is the hole current injected into the neutral n -region. I_n is the electron current injected into the neutral p -region.
Saturation current (A)	$I_s = A q n_i^2 \left(\frac{D_p}{L_p N_D} + \frac{D_n}{L_n N_A} \right)$	
Amount of charge stored in (one side) of the depletion region (C)	$q_j = q x_p N_A A = q x_n N_D A$ $= q \left(\frac{N_A N_D}{N_A + N_D} \right) W_{dep} A$	

Depletion or junction capacitance (F)	$C_j = \frac{\epsilon_s A}{W_{dep}}$ $C_j = A \left[\frac{q\epsilon_s}{2} \left(\frac{N_A N_D}{N_A + N_D} \right) \frac{1}{(V_0 - V)} \right]^m$ $C_j = A \times C_{j0} \left(1 - \frac{V}{V_0} \right)^m$ $C_{j0} = \left[\frac{q\epsilon_s}{2} \left(\frac{N_A N_D}{N_A + N_D} \right) \frac{1}{V_0} \right]^m$	<p>m is a value that ranges between 1/3 to 1/2.</p> <p>$\epsilon_s = 11.7 \times \epsilon_0$ for Si $\epsilon_0 = 8.854 \times 10^{-14}$ F cm⁻¹.</p>
Small signal (or incremental) resistance of the pn junction diode (Ω)	$r_d = \frac{nV_T}{I_D}$	<p>I_D is the (d.c.) diode current at the operating point, n is a value between 1 and 2.</p>

III. Bipolar Junction Transistor (BJT)

Quantity	Equation	Remarks
Magnitude of the diffusion current of the minority carriers (electrons) in the base of an npn BJT (A)	$ i_{En} = \left qAD_n \frac{n_p(0) - n_p(w_B)}{0 - w_B} \right $	D_n is the diffusivity of the electrons in the base, w_B is the width of the neutral part of the base, $n_p(0)$ and $n_p(w_B)$ are the concentrations of the electrons on the base side of the edges of the E-B and C-B space charge regions respectively.
Collector current of an npn BJT (A)	$i_C = I_S \exp\left(\frac{v_{BE}}{V_T}\right)$	
Collector saturation current of an npn BJT (A)	$I_S = qA \frac{D_n}{w_B} \frac{n_i^2}{N_{AB}}$	Note that the symbol I_S is also the symbol for the saturation current of a p-n junction diode, but the expression is different.
Base current of an npn BJT (A)	$i_B = \frac{I_S}{\beta} \exp\left(\frac{v_{BE}}{V_T}\right)$ <p>where $\beta = \frac{D_n}{D_p} \frac{L_p}{w_B} \frac{N_{DE}}{N_{AB}}$</p>	The expression for β here is for an npn BJT with a long emitter.
Common emitter current gain of a BJT (general definition)	$\beta = \frac{i_C}{i_B}$	
Common base current gain of a BJT (general definition)	$\alpha = \frac{i_C}{i_E}$	
Relationship between α and β	$\beta = \frac{\alpha}{1 - \alpha}$	

Collector current of an npn BJT, with Early effect taken into account (A)	$i_C = I_S \exp\left(\frac{v_{BE}}{V_T}\right) \left(1 + \frac{v_{CE}}{V_A}\right)$	V_A is the Early voltage.
Transconductance in the small signal equivalent circuit of a BJT (Ω^{-1})	$g_m = \frac{I_C}{V_T} \Big _{\text{at bias point}}$	I_C is the value of the collector current at the d.c. operating (bias) point.
Input resistance in the small signal equivalent circuit of a BJT (Ω)	$r_\pi = \frac{\beta}{g_m}$	
Output resistance in the small signal equivalent circuit of a BJT (Ω)	$r_o \approx \frac{V_A}{I_C}$	I_C is the value of the collector current at the d.c. operating (bias) point.

IV. Metal Oxide Semiconductor Field Effect Transistor (MOSFET)

<u>Quantity</u>	<u>Equation</u>	<u>Remarks</u>
Drain current of an n-MOSFET operating in the linear region	$i_D = \mu_n \frac{W}{L} C_{ox} \left[(v_{GS} - V_{TH}) v_{DS} - \frac{1}{2} v_{DS}^2 \right]$ $= 2K_n \left[(v_{GS} - V_{TH}) v_{DS} - \frac{1}{2} v_{DS}^2 \right]$	Valid for $v_{DS} \leq v_{GS} - V_{TH}$
Drain current of an n-MOSFET operating in the saturation region	$i_D = i_{Dsat} = \frac{1}{2} \mu_n \frac{W}{L} C_{ox} (v_{GS} - V_{TH})^2$ $= K_n (v_{GS} - V_{TH})^2$	Valid for $v_{DS} \geq v_{GS} - V_{TH}$
Transconductance parameter of an n-MOSFET	$K_n = \frac{1}{2} \mu_n \frac{W}{L} C_{ox}$	
Drain current of a p-MOSFET operating in the linear region	$ i_D = \mu_p \frac{W}{L} C_{ox} \left[(v_{GS} - V_{TH}) v_{DS} - \frac{1}{2} v_{DS} ^2 \right]$ $= 2K_p \left[(v_{GS} - V_{TH}) v_{DS} - \frac{1}{2} v_{DS} ^2 \right]$	Valid for $ v_{DS} \leq v_{GS} - V_{TH} $
Drain current of a p-MOSFET operating in the saturation region	$ i_D = i_{Dsat} = \frac{1}{2} \mu_p \frac{W}{L} C_{ox} (v_{GS} - V_{TH})^2$ $= K_p (v_{GS} - V_{TH})^2$	Valid for $ v_{DS} \geq v_{GS} - V_{TH} $
Transconductance parameter of a p-MOSFET	$K_p = \frac{1}{2} \mu_p \frac{W}{L} C_{ox}$	
Gate oxide capacitance (per unit gate area) of a MOSFET	$C_{ox} = \frac{\epsilon_{ox}}{t_{ox}}$	

Drain-to-source resistance in the large signal model of the n-MOSFET operating in the linear region	$R_{DS} = \frac{1}{2K_n(V_{GS} - V_{TH})}$	V_{GS} is the magnitude of the gate-to-source voltage, at the d.c. operating point.
Drain-to-source resistance in the large signal model of the p-MOSFET operating in the linear region	$R_{DS} = \frac{1}{2K_p(V_{GS} - V_{TH})}$	V_{GS} is the magnitude of the gate-to-source voltage, at the d.c. operating point.
Transconductance in the small signal equivalent circuit of an n-MOSFET operating in the saturation region	$g_m = 2K_n(V_{GS} - V_{TH}) = 2\sqrt{K_n I_D}$	I_D and V_{GS} are the magnitudes of the drain current and gate-to-source voltage, respectively, at the d.c. operating point.
Transconductance in the small signal equivalent circuit of a p-MOSFET operating in the saturation region	$g_m = 2K_p(V_{GS} - V_{TH}) = 2\sqrt{K_p I_D }$	I_D and V_{GS} are the magnitudes of the drain current and gate-to-source voltage, respectively, at the d.c. operating point.
Output resistance in the small signal equivalent circuit of a MOSFET operating in the saturation region	$r_o \approx \frac{V_A}{I_D} = \frac{1}{\lambda I_D}$	I_D is the magnitude of the drain current at the d.c. operating point.
Drain current of an n-MOSFET operating in the saturation region, including channel length modulation effect	$i_D = K_n(v_{GS} - V_{TH})^2(1 + \lambda v_{DS})$	Valid for $v_{DS} \geq v_{GS} - V_{TH}$ λ is the channel length modulation factor.
Drain current of a p-MOSFET operating in the saturation region, including channel length modulation effect	$ i_D = K_p(v_{GS} - V_{TH})^2(1 + \lambda v_{DS})$	Valid for $ v_{DS} \geq v_{GS} - V_{TH} $ λ is the channel length modulation factor.